

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of

: **Confirmation No. 4423**

Tomohiro OKUMURA et al.

: Docket No. 2001-1089A

Serial No. 09/918,823

: Group Art Unit 2821

Filed August 1, 2001

: Examiner T. Phan

PLASMA PROCESSING METHOD
AND APPARATUS THEREOF

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

*In response to the Office Action of May 21, 2003, a three month Extension of Time having
been obtained, please consider the following remarks.*

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TECHNOLOGY CENTER 2800